



Basic Details

Organisation Chain	Indian Institute of Technology Madras Deputy Registrar (Industrial Consultancy and Sponsored Research)		
Tender Reference Number	EE/2020/013/ANBU/MT RF DC MSDS		
Tender ID	2020_IIT-M_552226_1		
Tender Type	Open Tender	Form of contract	Supply
Tender Category	Goods	No. of Covers	2
Payment Mode	Not Applicable	Is Multi Currency Allowed For BOQ	No
Is Multi Currency Allowed For Fee	No		

Cover Details, No. Of Covers - 2

Cover No	Cover	Document Type	Description
1	Fee/PreQual/Technical	.pdf	Technical bid
2	Finance	.pdf	Financial bid

Tender Fee Details, [Total Fee in ₹ * - 0.00]

Tender Fee in ₹	0.00	Fee Payable To	NA	Fee Payable At	NA
Tender Fee Exemption Allowed	NA				

EMD Fee Details

EMD Amount in ₹	0.00	EMD Exemption Allowed	NA
EMD Fee Type	NA	EMD Percentage	NA
EMD Payable To	NA	EMD Payable At	NA

Work /Item(s)

Title	Multi-target RF, DC Magnetron Sputtering Deposition System				
Work Description	Multi-target RF, DC Magnetron Sputtering Deposition System				
Pre Qualification Details	Please refer Tender documents.				
Tender Value in ₹		Product Category	Miscellaneous Goods	Sub category	NA
Contract Type	Tender	Bid Validity(Days)	90	Period Of Work(Days)	21
Location	Department of Electrical Engineering	Pincode	600036	Pre Bid Meeting Place	NA
Pre Bid Meeting Address	NA	Pre Bid Meeting Date	NA	Bid Opening Place	Department of Electrical Engineering

Critical Dates

Publish Date	17-Aug-2020 03:40 PM	Bid Opening Date	08-Sep-2020 04:00 PM
Document Download / Sale Start Date	17-Aug-2020 03:50 PM	Document Download / Sale End Date	07-Sep-2020 05:00 PM
Clarification Start Date	NA	Clarification End Date	NA
Bid Submission Start Date	18-Aug-2020 09:00 AM	Bid Submission End Date	07-Sep-2020 05:00 PM

Tender Documents

NIT Document	S.No	Document Name	Description	Document Size (in KB)
	1	Tendernotice_1.pdf	As per tender document	945.77

Work Item Documents	S.No	Document Type	Document Name	Description	Document Size (in KB)
	1	Tender Documents	OPEN TENDER - Multi-target RF, DC Magnetron Sputtering Deposition System.pdf	OPEN TENDER - Multi-target RF, DC Magnetron Sputtering Deposition System	945.77

2	Additional Documents	ANNEXURE - 1.pdf	ANNEXURE-1	285.2
3	Additional Documents	EMD.pdf	EMD	233.41

Tender Inviting Authority

Name	The Senior Manager
Address	The Senior Manager, Project Purchase, ICSR Building, Ground floor, I.I.T. Madras, Chennai - 600 036

Tender Creator Details

Created By	Vijay Shankar B
Designation	Assistant Registrar
Created Date	17-Aug-2020 02:54 PM